



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

**Nathan R. Brown**

**Serial No.: 10/715,248**

**Filed: November 17, 2003**

**For: POLISHING SYSTEMS FOR USE  
WITH SEMICONDUCTOR SUBSTRATES  
INCLUDING DIFFERENTIAL PRESSURE  
APPLICATION APPARATUS**

**Confirmation No.: 4988**

**Examiner: D. Thomas**

**Group Art Unit: 3723**

**Attorney Docket No.: 2269-4375.2US  
(99-1029.02/US)**

**Notice of Allowance Mailed:**

**November 10, 2004**

**Express Mail Mailing Label No.: EL 994826066 US**

**Date of Deposit with USPS: February 8, 2005**

**Person making Deposit: Steve Wong**

**AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)**

**Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450**

**Sir:**

**Please amend the above-referenced application as follows:**